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BIBDATASHEET

CONFIRMATION NO. 3974

Bib Data Sheet

SERIAL NUMBER 10/036,156	FILING OR 371(c) DATE 12/26/2001 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 29936/37830
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APPLICANTS

Dae Gyu Park, Kyungki-Do, KOREA, REPUBLIC OF;
 Heung Jae Cho, Kyungki-Do, KOREA, REPUBLIC OF;
 Kwan Yong lim, Kyungki-Do, KOREA, REPUBLIC OF;

**** CONTINUING DATA *********** FOREIGN APPLICATIONS *******

REPUBLIC OF KOREA 2000-85582 12/29/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 01/30/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 4	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 1
Verified and Acknowledged	Examiner's Signature _____ Initials _____				

ADDRESS

04743

TITLE

METHOD OF FORMING A METAL GATE IN A SEMICONDUCTOR DEVICE USING ATOMIC LAYER DEPOSITION PROCESS

FILING FEE RECEIVED 740	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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APPLICANTS Dae Gyu Park, Kyungki-Do, KOREA, REPUBLIC OF; Heung Jae Cho, Kyungki-Do, KOREA, REPUBLIC OF; Kwan Yong lim, Kyungki-Do, KOREA, REPUBLIC OF;				
** CONTINUING DATA ***** _____				
** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 2000-85582 12/29/2000 _____				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/30/2002				
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INDEPENDENT CLAIMS 1				
ADDRESS 04743				
TITLE Method of forming a metal gate in a semiconductor device				
FILING FEE RECEIVED 740	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	